IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Young-Kwan Lee, et al.		
Serial No Pending 10/76665	Filing Date: January 27, 2004		
Title of Application:	Antenna Structure For Inductively Coupled Plasma Generator		

Commissioner for Patents Post Office Box 1450 Alexandria, VA 22313-1450

Information Disclosure Statement by Applicants

Dear Sir:

As a means of complying with the duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references (copies of the listed patents enclosed).

		U.	.S. Patent D	ocuments		
Exam. Initials	Class/ Subclass.	Document No.		Date	Name	
TXL	376/123	5,289,509		1994	Moeller	
Exam.			eign Patent	Document		
Initials	Document No.		Date		Country	
TXL	1 079 671		2001	EP		
TXL	2000-323298		2000	JP (wi	th English abstract)	
TXL	2000-048998		2000	JP (wi	JP (with English abstract)	

The listed patents pertain in a general way to the subject matter of the application, but are not necessarily considered to be analogous prior art.

Respectfully submitted,

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